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M	10	Otto-M et al. " Engineering (N	Characterization an etherlands), vol 57-	d app 58, p	olication of a UV-base pages 361-6, Septemb	d impo per 20	rint techinque" 01.	Microelectron	ic	
	1R	Beck-M et al., the 2001 1st i	"Improving nanoim EEE Conference on	print Nano	Lithography stamps fo technology, IEE-Nano	or 10r 2001	nm features", F 1, pages 17-22	Proceedings of 2, 2001.		
	18				\ N				!	

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181	1A	5772905	Jun 30, 1998	Ch	ou	\perp				
7	1B	6069380	May 30, 2000	Ch	ou, et al					
	1C 6103540 Aug 15, 2000 Rus			ssell, et al				_		
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	1F	6197641	Mar 06, 2001	He	ergenrother, et al					
	1G	6248674	Jun 19, 2001	Ka	mis, et al					
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	11				Itermeier, et al					
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	10	Vieu-C et al. Micro- and N	"Bectron beam litho anotechnology', App	grapl blied	ny, resolution limits and Surface Science vol.16	d ap 34, p	plications", 'Surf ages 111-17, Se	ace Science in pt 01, 2000		
Pat	11	Hirai-Y et al. Japan Soc. A	"Nano-imprint lithog oppl. Phys., IEEE Bed	raphy	y for single electron tur Device Soc., In pages	nneli 122	ng devices using -123, 1999	novel mold"		
A	1	tunneling dev	"Novel mold fabrical vices", Japanese Jou 7275 Dec 1999	tion f urnal	for nano-imprint lithogr of Applied Physics- Pa	aphy irt-1,	to fabricate sing vol 38, No. 128	gle-electron ,		
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LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE					APPLICANT						
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11/	2A	4272744	Jun 09, 1981	Sc	huegraf						
90		5138408	Aug 11, 1992	An	do						
-		5285081	Feb 08, 1994	An	ido						
-	┷	5475341	Dec 12, 1995	Re	ed						
-	2E 5937295 2F 5990516 2G 6090666		Aug 10, 1999	Cr	en, et al						
			Nov 23, 1999	M	amose, et al						
-			Jul 18, 2000	Ue	eda, et al						
-		6103540	Aug 15, 2000		issell, et al						
-	21 6128216 2J 6153534		Oct 03, 2000 Nov 28, 2000		oble, Jr., et al						
-					ong, et al						
7/2	 / /	6168979	Jan 02, 2001		m, et al						
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3B 6256767 Jul 03, 2001 Kuekes, et al. 3C 6261938 Jul 17, 2001 Kuekes, et al. 3D 6264450 Sep 25, 2001 Chen, et al. 3E 6319566 Nov 20, 2001 Polanyi, et al. 3F 6375870 Apr 23, 2002 Visovsky, et al. 3G 6518156 Feb 11, 2003 Chen, et al.	
3C 6261938 Jul 17, 2001 Kuekes, et al 3D 6264450 Sep 25, 2001 Chen, et al 3E 6319566 Nov 20, 2001 Polanyi, et al 3F 6375870 Apr 23, 2002 Visovsky, et al 3G 6518156 Feb 11, 2003 Chen, et al	
3E 6319566 Nov 20, 2001 Polanyi, et al 3F 6375870 Apr 23, 2002 Visovsky, et al 3G 6518156 Feb 11, 2003 Chen, et al	
3F 6375870 Apr 23, 2002 Visovsky, et al 3G 6518156 Feb 11, 2003 Chen, et al	
3G 6518156 Feb 11, 2003 Chen, et al	
31 6534414 Mar 18, 2003 Wang, et al	
3J 6544846 Apr 08, 2003 Ahn, et al	
A 3K 6559648 May 06, 2003 Baumgaertl, et al	
3L	
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OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)	
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14	4A	HO001570	Aug 1996	Lu	x, et al				
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